

PATENT NUMBER

## U.S. UTILITY Patent Application

**O.L.P.E.**

**PATENT DATE**

SCANNED

**Q.A.**

**APPLICATION NO.**

**CONT/PRIOR**

**CLASS**

SUBCLASS

ART UNIT  
2723

**EXAMINER**

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Polishing apparatus

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PTO-2040  
12/89

ISSUING CLASSIFICATION

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2000

(S-102) 1/1/11

NOTICE OF A RECONVOCATION

## ISSUE FIVE

Amount Due

**Out Puts**

ISSUE BATCH NUMBER

FILED WITH: ☒ DISK (CRP) ☐ FICKE ☐ CO-ROM

Amount to be paid on first month (1950)

(FACE)